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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE (Attorney Docket No. 100209)

AUG 0 3 2006

First Inventor: Francesco de Rege Thesauro

Serial No.:

10/807,944

Filing Date: March 24, 2004

Title: Chemical-Mechanical Polishing

Composition and Method for Using

the Same

Examiner: George, Patricia Ann

Art Unit: 1765

Certificate of Facsimile Transmission

I. Mariejose Monsalve, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on D 2

entered per RCE filed 2/1/07

RESPONSE TO FINAL OFFICE ACTION

Mail Stop Amendment **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

This is a reply to the June 26, 2006 Office Action for the above-captioned U.S. patent application.

Remarks begin on page 2 of this paper.

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